

Notice of References Cited	Application/Control No. 09/775,950	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Esaw T Abraham	Art Unit 2133	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,493,815	12-2002	Kim et al.	711/217
	B	US-6,314,534	11-2001	Agrawal et al.	714/702
	C	US-6,304,991	10-2001	Rowitch et al.	714/755
	D	US-5,996,104	11-1999	Herzberg, Hanan	714/755
	E	US-6,598,202	07-2003	Kim et al.	714/786
	F	US-6,334,197	12-2001	Eroz et al.	714/701
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.